Guojin Chen

☑ cgjcuhk@gmail.com • **⑤** gjchen.me • **in** dekura • **⑥** dekura Last updated on December 3, 2023

Current Position

Visiting Student, The University of Texas at Austin 2023.08 – Present

Supervisor: Prof. David Z. Pan

Ph.D. Candidate, The Chinese University of Hong Kong 2021.08 – Present

Supervisor : Prof. Bei Yu

Education

Ph.D. in Computer Science, The Chinese University of Hong Kong	2021 - Present
M.S. in Computer Science, The Chinese University of Hong Kong	2019 - 2020
B.S. in Computer Science, Huazhong University of Science and Technology	2015 - 2019

Research Interests

- Design for manufacturing (DFM) / Electronic design automation (EDA)
- Computational lithography / Resolution enhancement technologies
- Deep Learning for VLSI / Physics-informed deep learning

Publications [Google Scholar; 94+ citations, h-index: 5+]

Representative publications that I am a primary author on are highlighted.

Conference papers.....

- [C11] AlphaSyn: Logic Synthesis Optimization with Efficient Monte Carlo Tree Search Zehua Pei, Fangzhou Liu, Zhuolun He, **Guojin Chen**, Haisheng Zheng, Keren Zhu, and Bei Yu (**ICCAD 2023**) Proceedings of the 42th International Conference on Computer-Aided Design
- [C10] Physics-Informed Optical Kernel Regression Using Complex-valued Neural Fields

 Guojin Chen, Zehua Pei, Haoyu Yang, Yuzhe Ma, Bei Yu, and Martin Wong

 (DAC 2023) ACM/IEEE Design Automation Conference (Best score in DFM track.)
- [C9] DiffPattern: Layout Pattern Generation via Discrete Diffusion Zixiao Wang, Yunheng Shen, Wenqian Zhao, Yang Bai, Guojin Chen, Farzan Farnia, and Bei Yu (DAC 2023) ACM/IEEE Design Automation Conference
- [C8] GPU-accelerated Matrix Cover Algorithm for Multiple Patterning Layout Decomposition Guojin Chen, Haoyu Yang, and Bei Yu (SPIE 2023) DTCO and Computational Patterning II
- [C7] Efficient Point Cloud Analysis Using Hilbert Curve.
 Wanli Chen, Xinge Zhu, Guojin Chen, and Bei Yu
 (ECCV 2022) European Conference on Computer Vision
- [C6] AdaOPC: A Self-Adaptive Mask Optimization Framework For Real Design Patterns Wenqian Zhao, Xufeng Yao, Ziyang Yu, **Guojin Chen**, Yuzhe Ma, Bei Yu, and Martin Wong (**ICCAD 2022**) Proceedings of the 41th International Conference on Computer-Aided Design
- [C5] LayouTransformer: Generating Layout Patterns with Transformer via Sequential Pattern Modeling Liangjian Wen, Yi Zhu, Lei Ye, **Guojin Chen**, Bei Yu, Jianzhuang Liu, and Chunjing Xu (ICCAD 2022) Proceedings of the 41th International Conference on Computer-Aided Design
- [C4] DevelSet: Deep Neural Level Set for Instant Mask optimization

 Guojin Chen, Ziyang Yu, Hongduo Liu, Yuzhe Ma, and Bei Yu

 (ICCAD 2021) Proceedings of the 40th International Conference on Computer-Aided Design

- [C3] Learning Point Clouds in EDA.
 Wei Li, Guojin Chen, Haoyu Yang, Ran Chen, and Bei Yu
 (ISPD 2021) ACM International Symposium on Physical Design
- [C2] DAMO: Deep Agile Mask Optimization for Full Chip Scale

 Guojin Chen, Wanli Chen, Yuzhe Ma, Haoyu Yang, and Bei Yu

 (ICCAD 2020) Proceedings of the 39th International Conference on Computer-Aided Design
- [C1] A GPU-enabled Level Set Method for Mask Optimization Ziyang Yu, Guojin Chen, Yuzhe Ma, and Bei Yu (DATE 2020) IEEE/ACM Proceedings Design, Automation and Test in Europe

Journal papers.....

- [J4] L2O-ILT: Learning to Optimize Inverse Lithography Techniques
 Binwu Zhu, Su Zheng, Ziyang Yu, **Guojin Chen**, Yuzhe Ma, Fan Yang, Bei Yu, and Martin Wong
 (**TCAD 2023**) *IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems*
- [J3] A GPU-Enabled Level-Set Method for Mask Optimization
 Ziyang Yu, Guojin Chen, Yuzhe Ma, and Bei Yu
 (TCAD 2023) IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems
- [J2] DevelSet: Deep Neural Level Set for Instant Mask optimization

 Guojin Chen, Ziyang Yu, Hongduo Liu, Yuzhe Ma, and Bei Yu

 (TCAD 2023) IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems
- [J1] DAMO: Deep Agile Mask Optimization for Full-Chip Scale

 Guojin Chen, Wanli Chen, Qi Sun, Yuzhe Ma, Haoyu Yang, and Bei Yu

 (TCAD 2022) IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems

Open Source Repositories

1. OpenOPC/OpenILT — ★52 — Open-source inverse lithography technology (ILT) framework	2023
2. ai4eda/awesome-Al4EDA — ★73 — A curated paper list of existing AI for EDA studies.	2023

Experiences

Research Assistant, The Chinese University of Hong Kong	2020 – 2021
Research Intern, Tencent	2018 – 2019
Awards	

Awards

Ph.D. Studentship	2021 – 2025
By Chinese University of Hong Kong, 2021-2025 Outstanding Graduate	2019
•	2019
By Huazhong University of Science and Technology	

Ongoing Projects

Source mask co-optimization from bilevel optimization perspective. Traditional SMO is hindered by slow, sequential and alternating optimizations without assured outcomes. I've redeveloped it using bilevel optimization and gradient-based methods, providing global perspective through upper-lower level gradient fusion for enhanced performance. Differentiable Computational Lithography. Revamping lithography with a GPU-accelerated, differentiable workflow based on Abbe imaging, using automatic differentiation to target diverse resolution enhancement objectives.

Professional Activities

Paper Review / External Review	
Design Automation Conference (DAC)	2021-2023
AAAI Conference on Artificial Intelligence (AAAI)	2022-2023
IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems (TCAD)	2022-2023